IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Mikako UJIIE et al.

Appln. No.:

Filed: HEREWITH

For: A SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants wish to make of record the documents cited in prior Application No. 10/225,163 filed August 22, 2002, whether cited by Applicants or by the Patent Office. The documents are listed on the attached Form PTO-1449.

Respectfully submitted,

NHS: 1mb

Miles & Stockbridge P.C. 1751 Pinnacle Drive Suite 500 McLean, Virginia 22102-3833 (703) 903-9000

Nelson H. Shapiro Reg. No. 17,095

April 16, 2004

FORM PTO-1449						Atty. Docket No.			Appln. No.	
FORM F10-1449						XA-9730A			211. 110.	
LIST OF DOCUMENTS CITED BY APPLICANT						AR-9730R				
						Applicant				
						Mikako UJIIE et al.				
						Filing Date			Group	
						HEREWITH				
U.S. PATENT DOCUMENTS										
Examiner Initial		Document Number Date			Name		Class	Sub		
	AA	6,200,121 3/13/01		l Tsuruta		425	12	7		
	AB	2002/0149102	10/02		Hashemi et al.		257	70	6	
	AC	6,448,507 9/02		Fontecha et al.		174	260	0		
	AD	5,336,931	8/94		Juskey et al.		257	78	7	
	AE	2001/0026959	7/02 11/02		Jimarez et al.		438	120	6	
	AF	2002/0084518			Haseb	Hasebe et al. Glenn et al.		670	6	
	AG	2002/0168798			Glenn			110	0	
	АН	2003/0042621			Chen	et al.	257	784	4	
	ΑI	2002/0125557	9/02		Chen et al.		257	686	686	
			FOREIGN	PA	TENT I	OCUMENTS		•		
Examiner Initial		Document Number Date			Country		Class	Sub- class	Translation	
	AJ	8-181166	7/12/96	JA	PAN				abstract	
	AK	7-45641	2/14/95	JA	PAN				abstract	
	AL	8-167678	6/25/96	JA	PAN				abstract	
	AM	2000-286271	10/13/00	JAPAN					abstract	
	AN	2000-12578	1/14/00	/00 JA		PAN			abstract	
	AO									
		OTHER (in	ncluding autho	r, t	itle, da	te, pertinent pa	ges, etc.)		
	AP									
	AQ									
	AR									
Examiner Date Considered										
EXAMINER with MPR		Initial if refer								

Include copy of this form with next communication to Applicant.